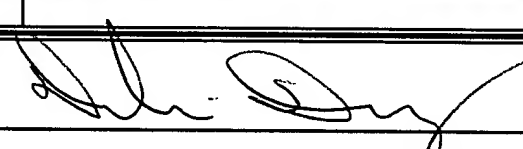





LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Attorney Docket No.</u> SEL 253		<u>Serial No.</u> 09/837,105	
			<u>Applicant</u> Kimura			
			<u>Filing Date</u> April 18, 2001		<u>Group</u>	
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
OTHER PUBLICATIONS (Including Author, Title, Date, Pertinent Pages)						
ΔΔ.	1) US Patent Application No. 09/631,067 (pending) to Kimura, including specification, claims, abstract, drawings and PTO filing receipt.					
EXAMINER: 			DATE CONSIDERED: 3/31/03			
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			Applicant Hajime KIMURA			
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D.D.	English Abstract re Japanese Patent Application No. JP 2001-051272 published February 23, 2001.					
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